

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) SEC:926D	Application Number 10/687, 838 TBD
				Applicant(s) Jung-Hwan Oh et al.	
				Filing Date 10/20/2003	Group Art Unit TBD 2818

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IP APPROPRIATE
ohm	A	6,022,772	02/08/2000	Watanabe et al.			
	B	5,545,585	08/13/1996	Wang et al.			
	C	2001/0034114	10/25/2001	Liaw			
	D	5,763,286	06/09/1998	Figura et al.			
	E	2001/0018248	08/30/2001	An			
	F	5,434,812	7/1995	Tseng			
	G	5,468,684	11/1995	Yoshimori et al.			
	H	5,885,865	3/1999	Liang et al.			
	I	6,168,987	1/2001	Jeng et al.			
	J	6,268,244	7/2001	Park			
ohm	K	2002/0000596 A1	1/2002	Carstensen			

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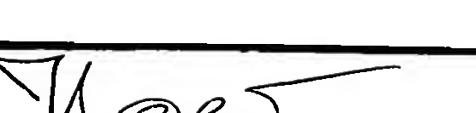
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
ohm	L	GB 2276980	10/12/1994	United Kingdom				
	M	4-3-259567	11/1991	Japan				
	N	4-5-6974	1/1993	Japan				
ohm	O	2001-57413	02/27/2001	Japan				

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

ohm	P	Combined Search and Examination Report Under Sections 17 and 18(3) from the UK Patent Office dated 9 July 2003.
ohm	Q	Fukuzumi et al., Liner-Supported Cylinder (LSC) Technology to realize Ru/Ta205/Ru Capacitor for Future DRAMs, 2000, IEEE, IEDM 00, pp. 793-96.

EXAMINER	<i>Noa</i>	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
dhn	R	2002/0019107 A1	2/2002	Lin et al.			
dhn	S	2002/0028553 A1	3/2002	Yokoyama et al.			
FOREIGN PATENT DOCUMENTS							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
						YES	NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED		02/14/05	

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